

Attorney's Docket No.: 07977-286001  
Client's Ref. No.: US5247

**OFFICIAL COMMUNICATION****FACSIMILE****FOR THE PERSONAL ATTENTION OF:****EXAMINER S. CROW****GROUP 1765 FAX NO: 703-<sup>872</sup>~~874~~-9310**

Number of pages including this page 19

Applicant : S. Yamazaki, et al.  
Serial No. : 09/966,689  
Filed : September 27, 2001

Art Unit : 1765  
Examiner : S. Crow  
Confirmation No.: 5005

**FACSIMILE COMMUNICATION**

Title : DRY ETCHING APPARATUS, ETCHING METHOD AND METHOD OF  
FORMING A WIRING

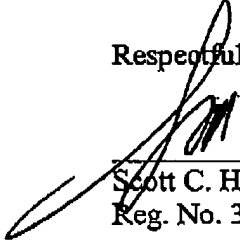
Commissioner for Patents  
Washington, D.C. 20231

Sir:

Attached to this facsimile communication cover sheet is a Response to Office Action,  
faxed this 6<sup>th</sup> day of February, 2003, to Group 1765, the United States Patent and Trademark  
Office.

Respectfully submitted,

Date: February 6, 2003

  
\_\_\_\_\_  
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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S. Yamazaki, et al.      Art Unit: 1765  
Serial No.: 09/966,689      Examiner: Kin-Chan Chen  
Filed : September 27, 2001      Confirmation No.: 5005  
Title : DRY ETCHING APPARATUS, ETCHING METHOD AND METHOD OF  
FORMING A WIRING

Commissioner for Patents  
Washington, D.C. 20231

RESPONSE

In response to the official action mailed 11/06/02, paper  
no. 11 in the above referenced case, please amend the  
application as follows:

In the claims:

Please amend claims 15, 18, 20, 22, 24, 26, 27 as follows:

5/20/01  
C1  
15. (Amended) An etching method using a dry etching  
apparatus provided with at least first, second and third  
electrodes, said first electrode being opposed to each other  
said second and third electrodes, the method comprising the  
steps of:  
disposing a substrate on said second and third electrodes  
in a chamber;

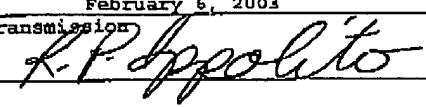
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February 6, 2003  
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